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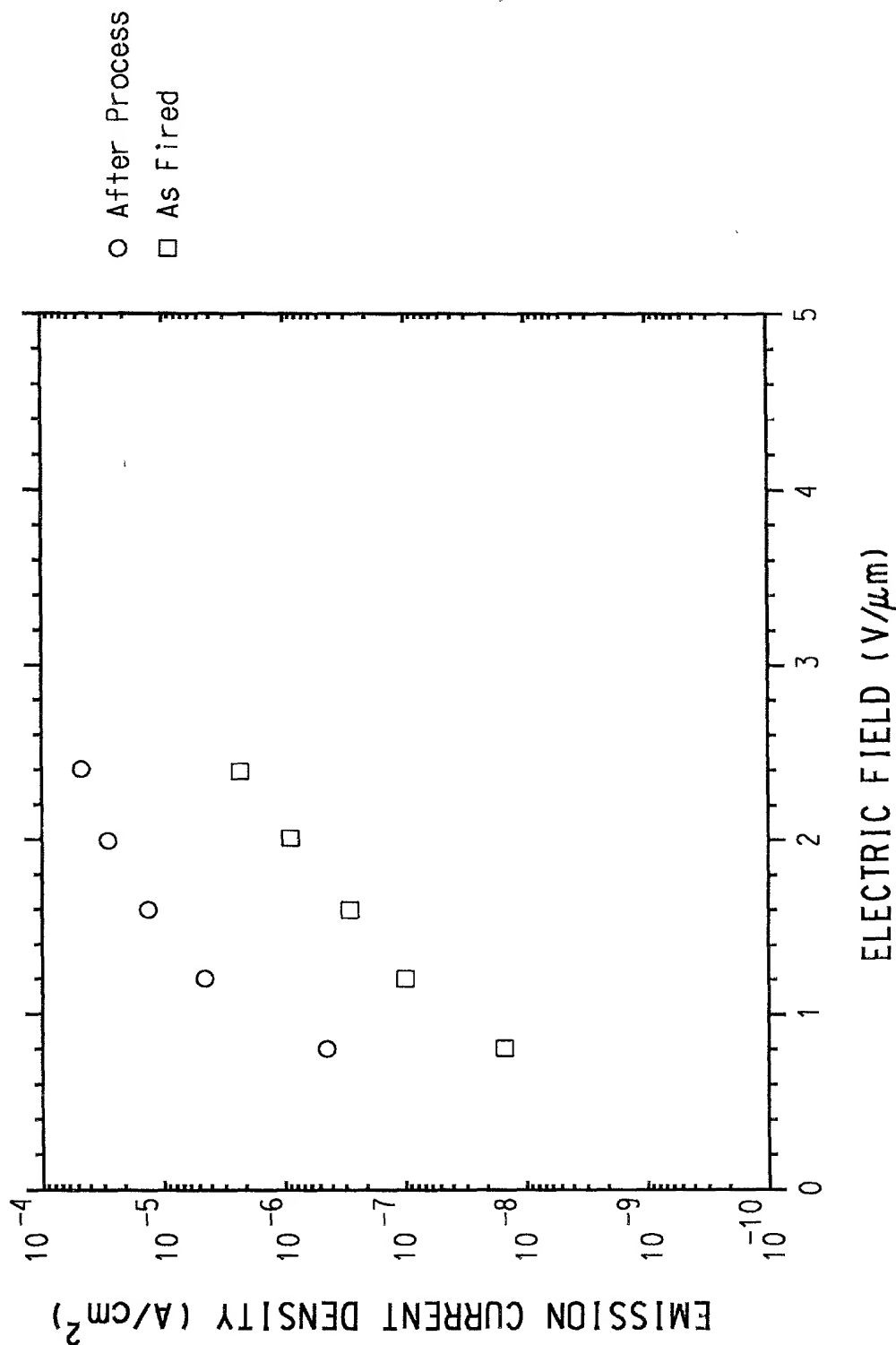


FIG. 1

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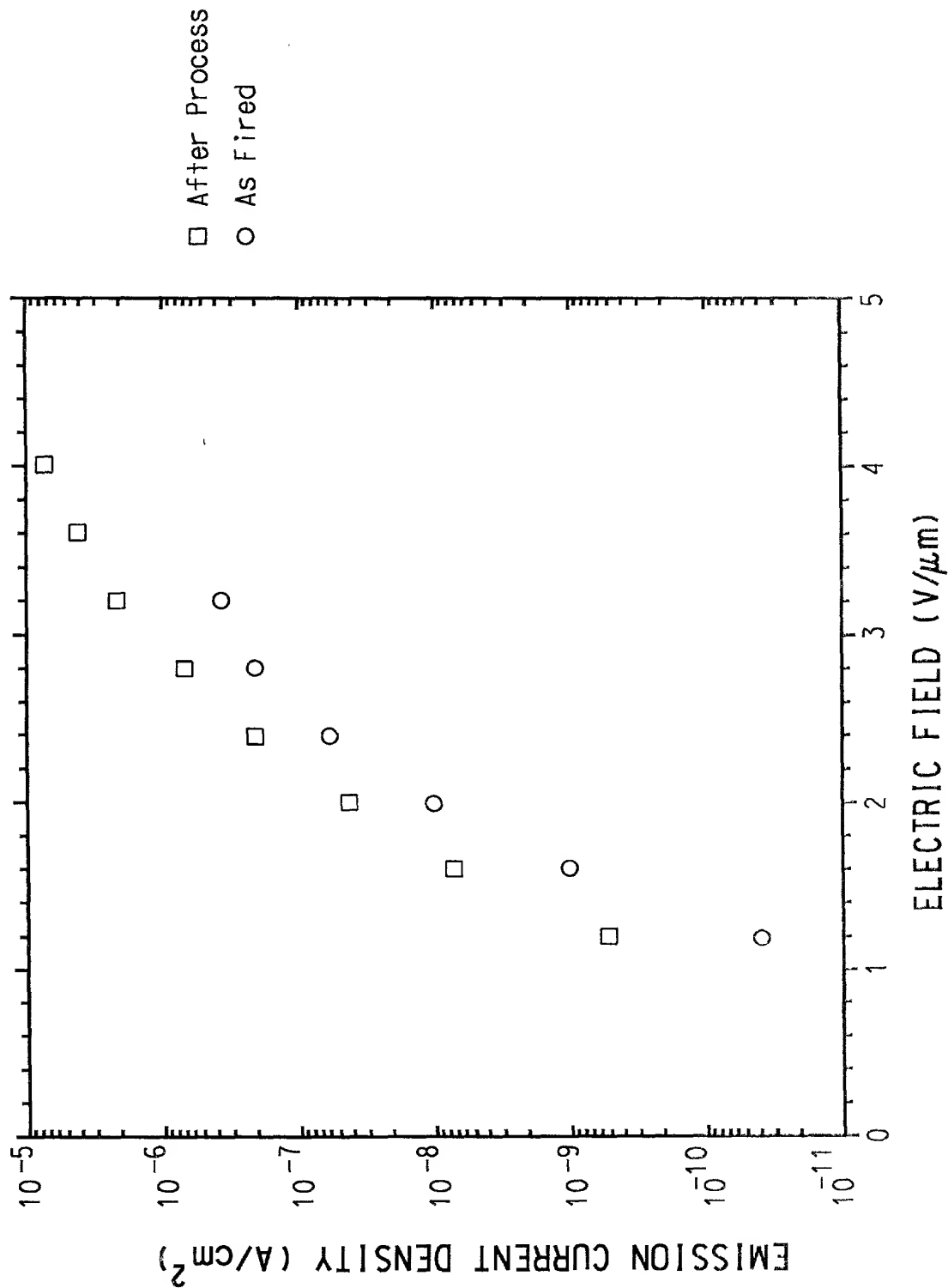


FIG. 2

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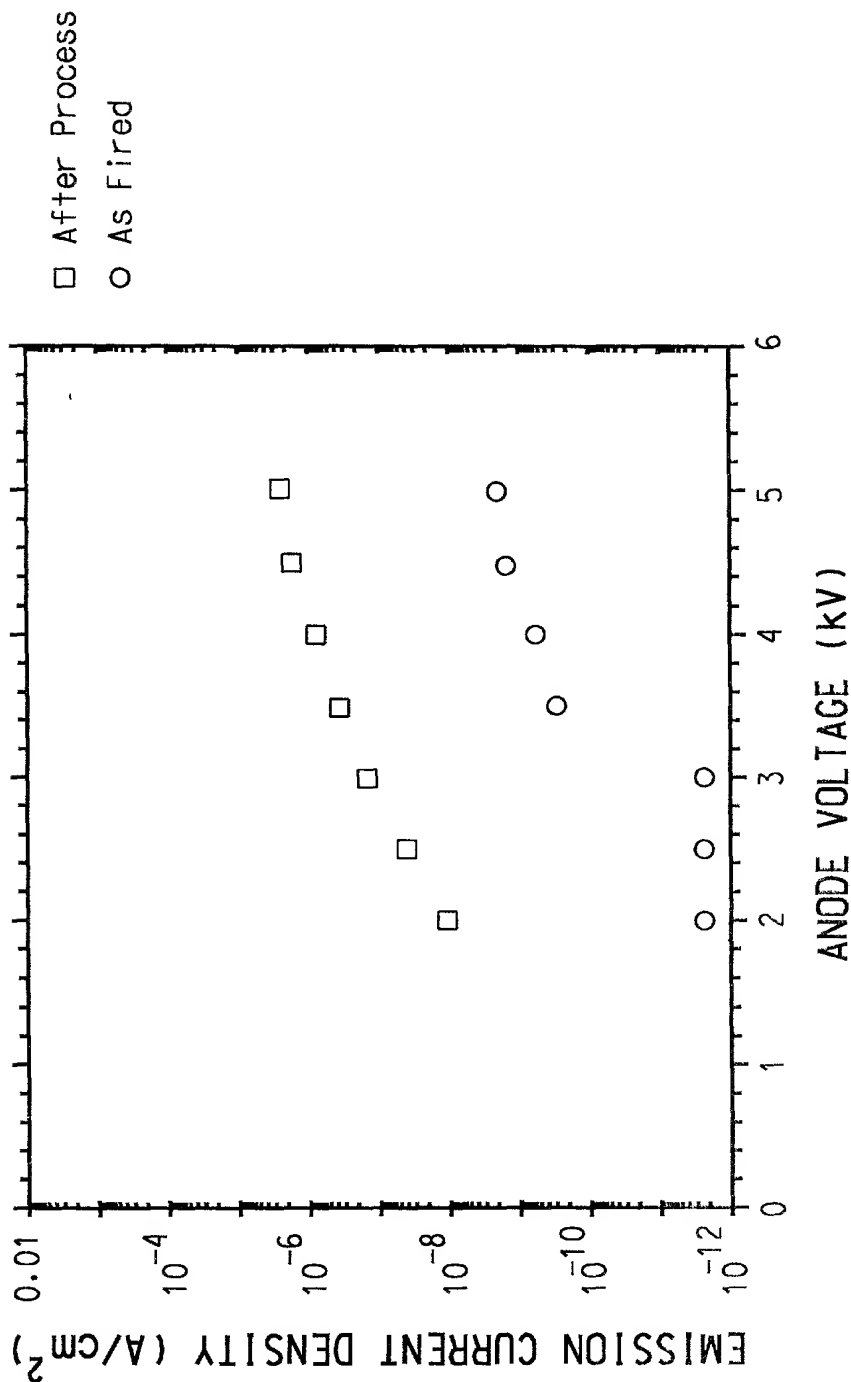


FIG. 3

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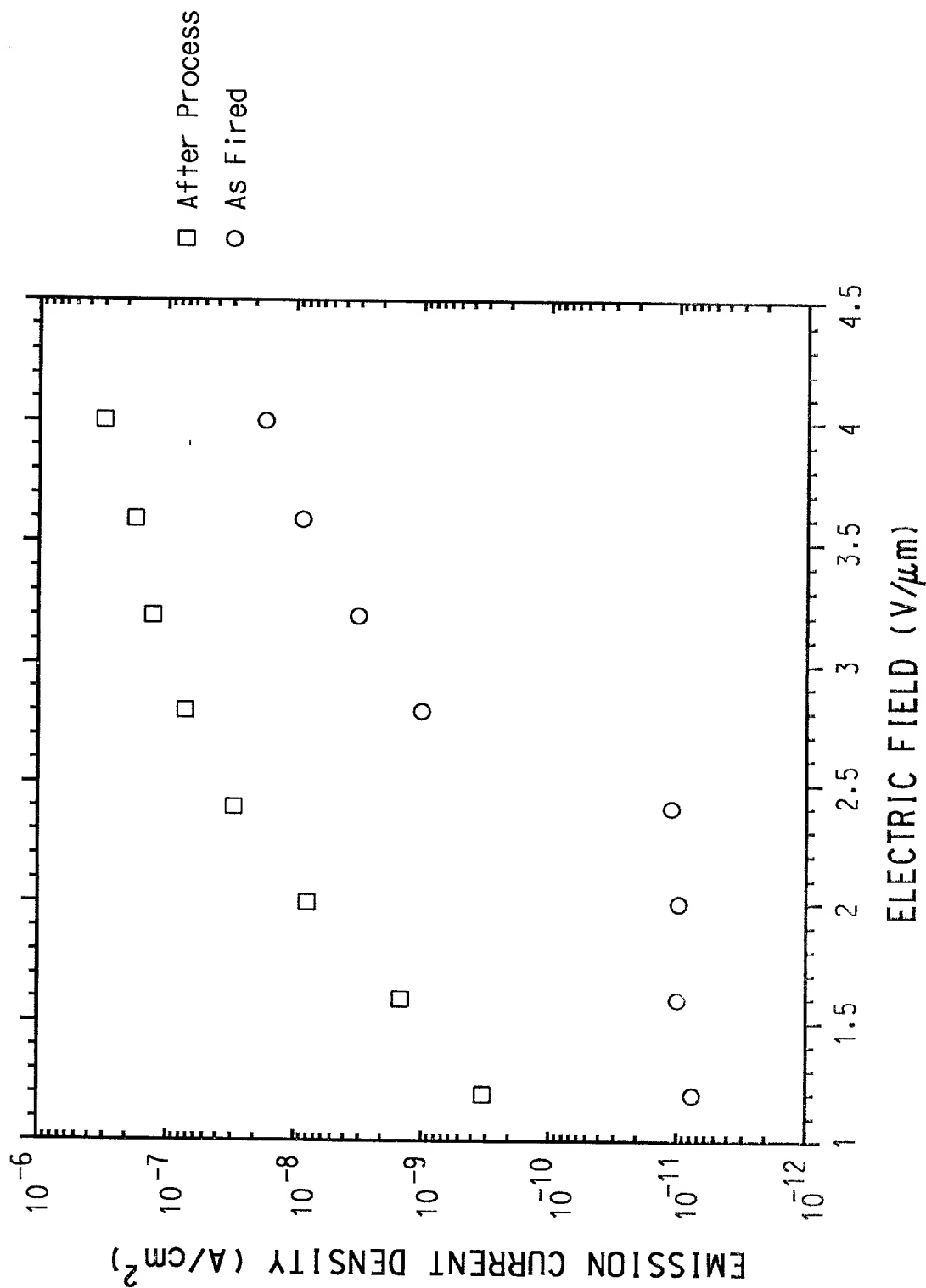
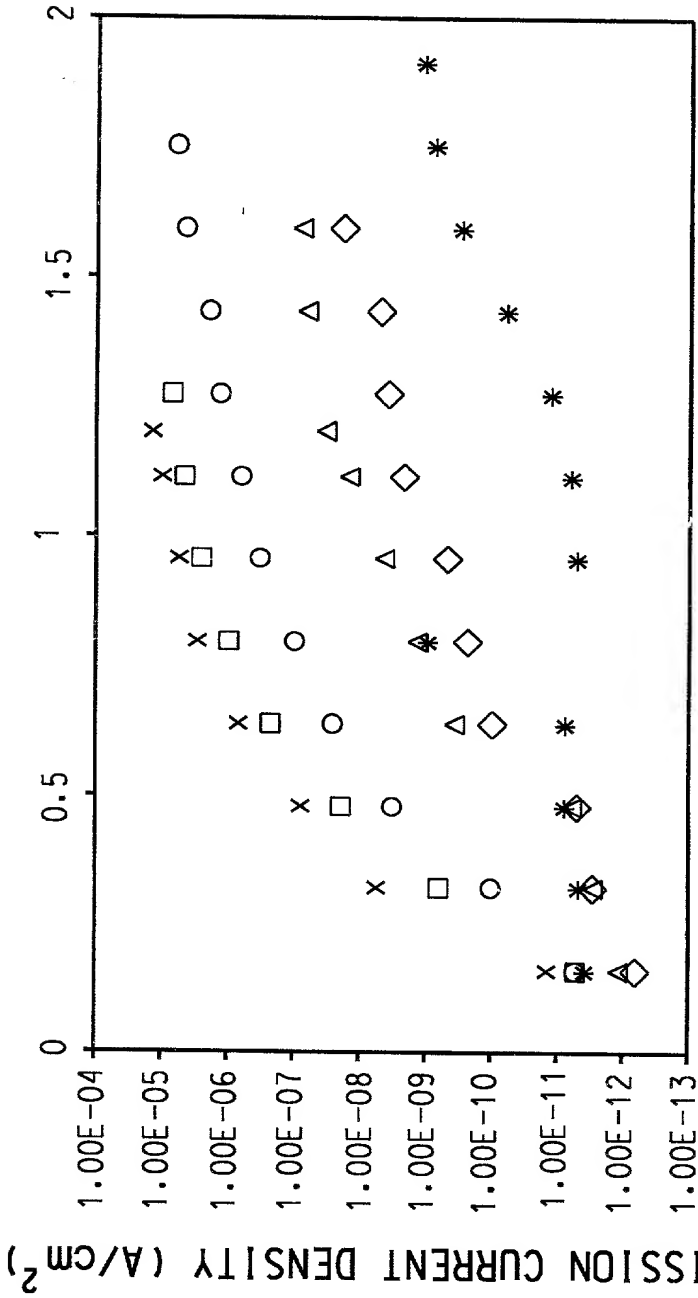


FIG. 4

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- ◇ Example 9 - As fired
- Example 9 - After process
- △ Example 10 - As fired
- x Example 10 - After process
- * Example 11 - As fired
- Example 11 - After process

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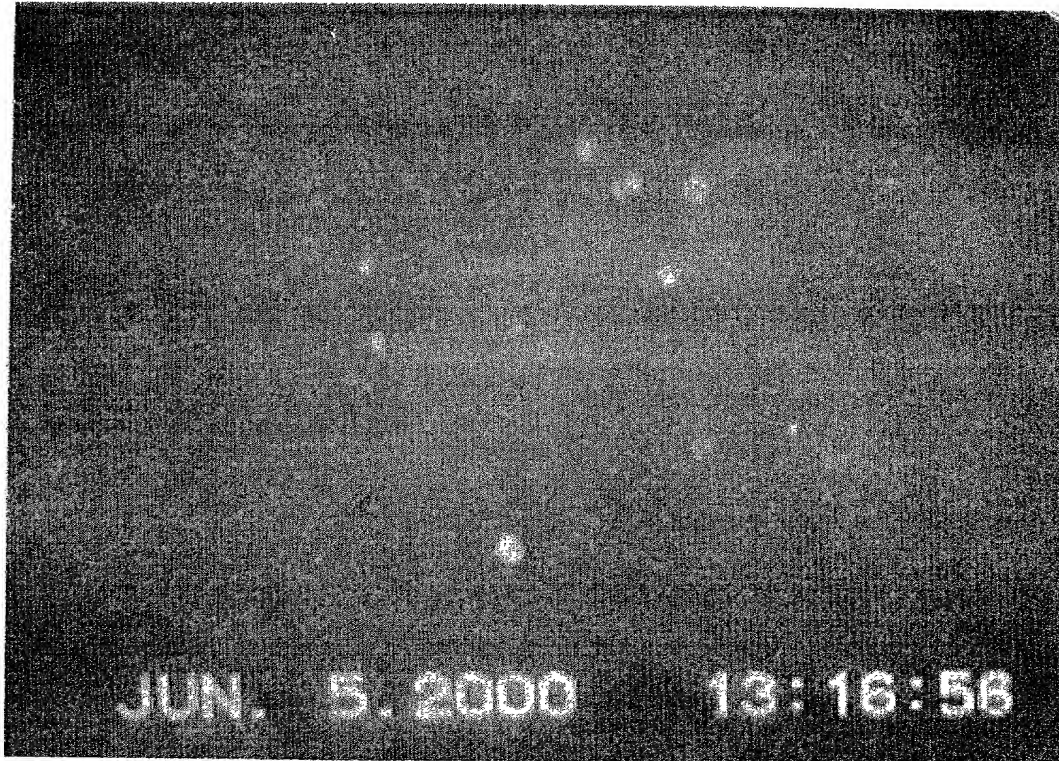


FIG. 6a

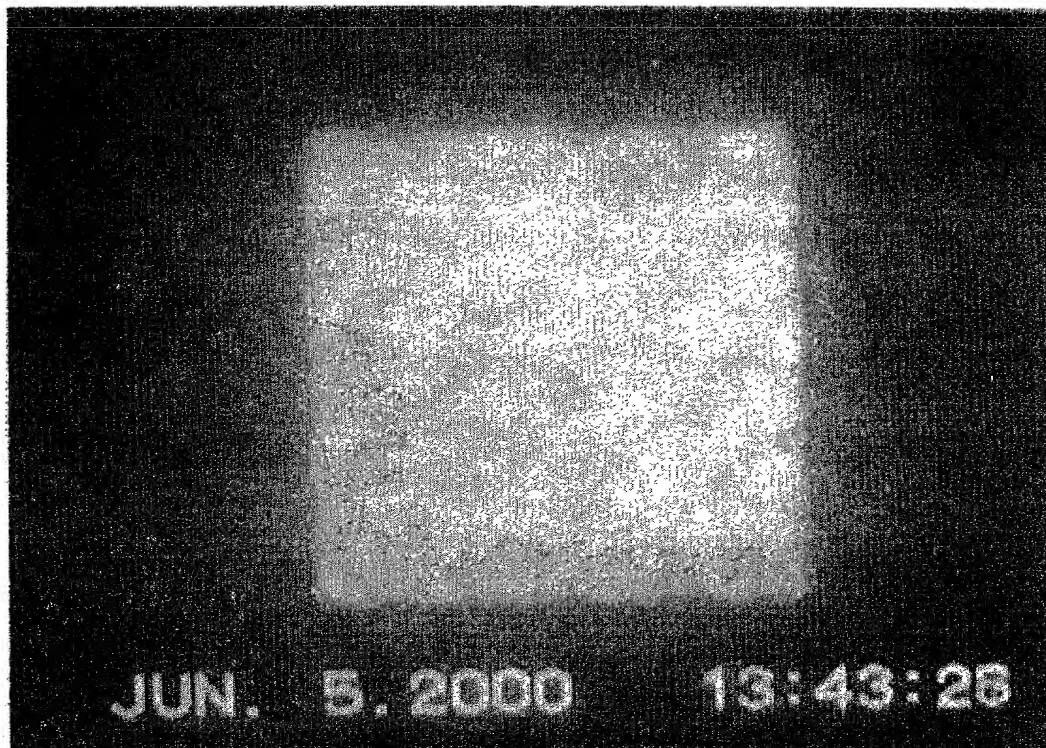


FIG. 6b

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FIG. 6c

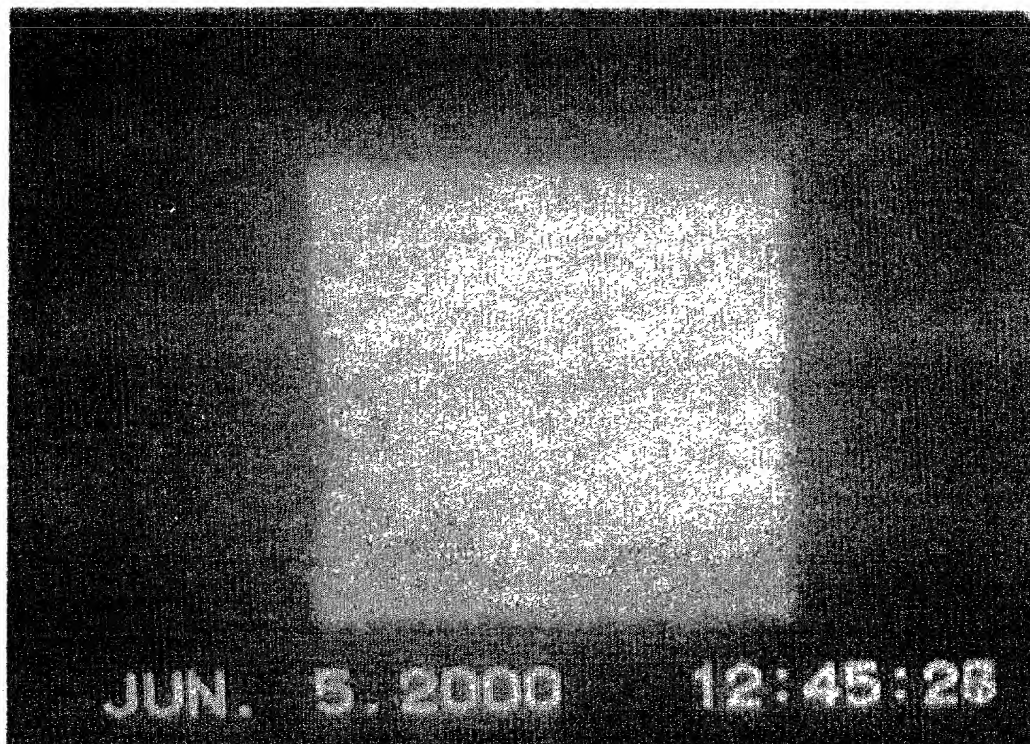


FIG. 6d

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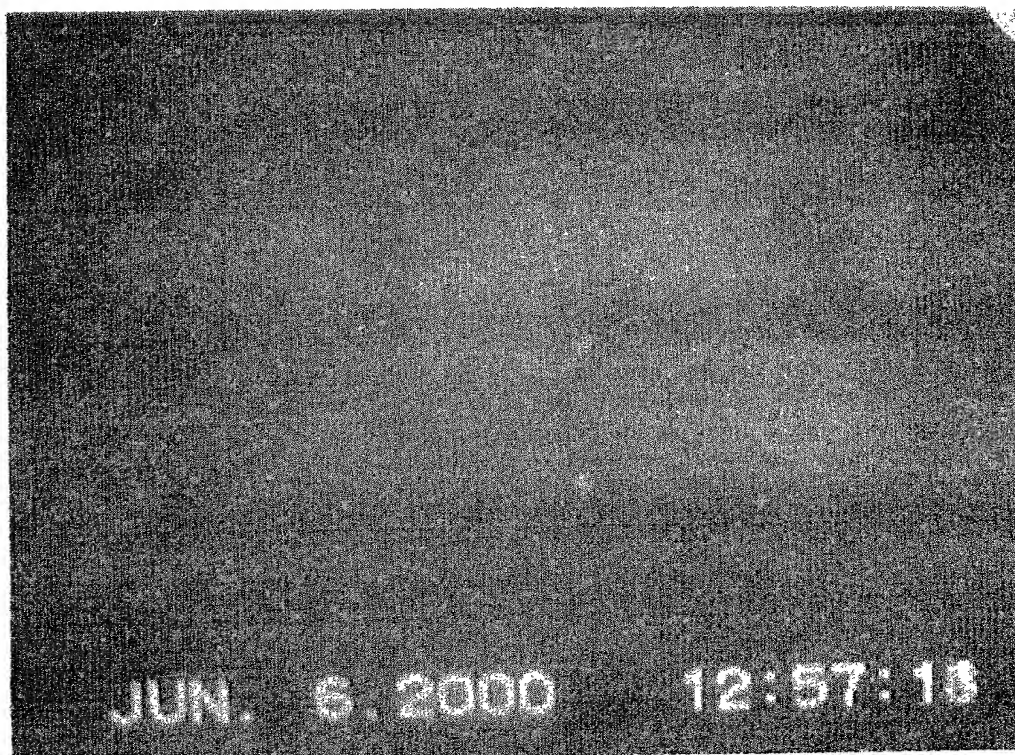


FIG. 6e

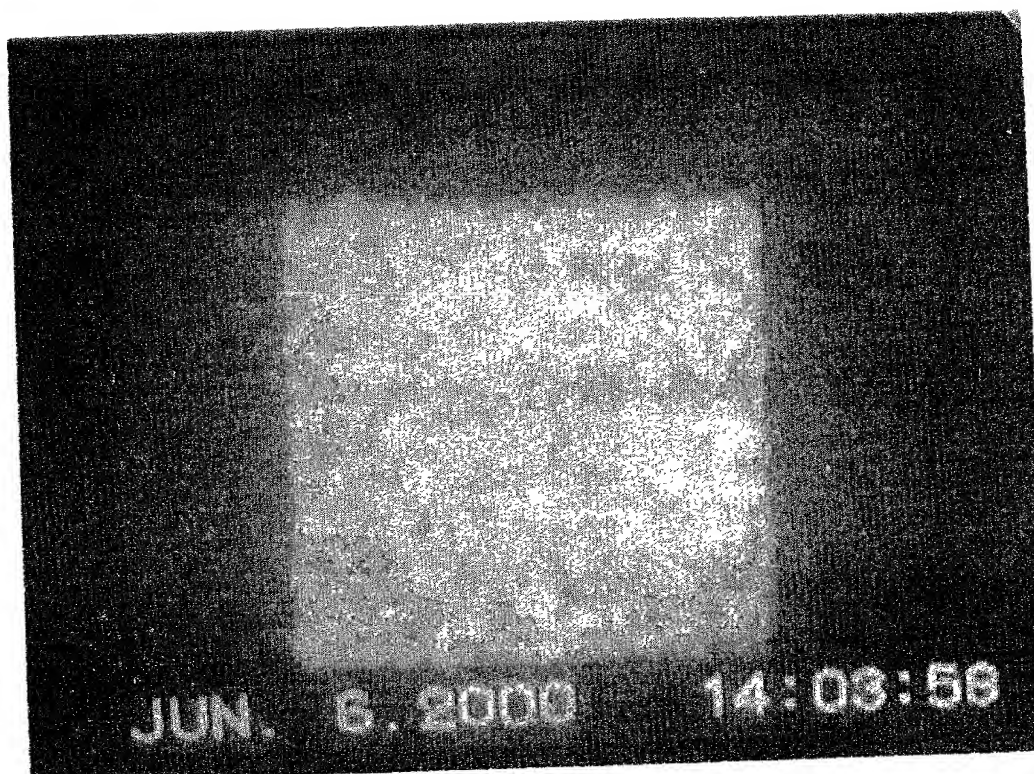
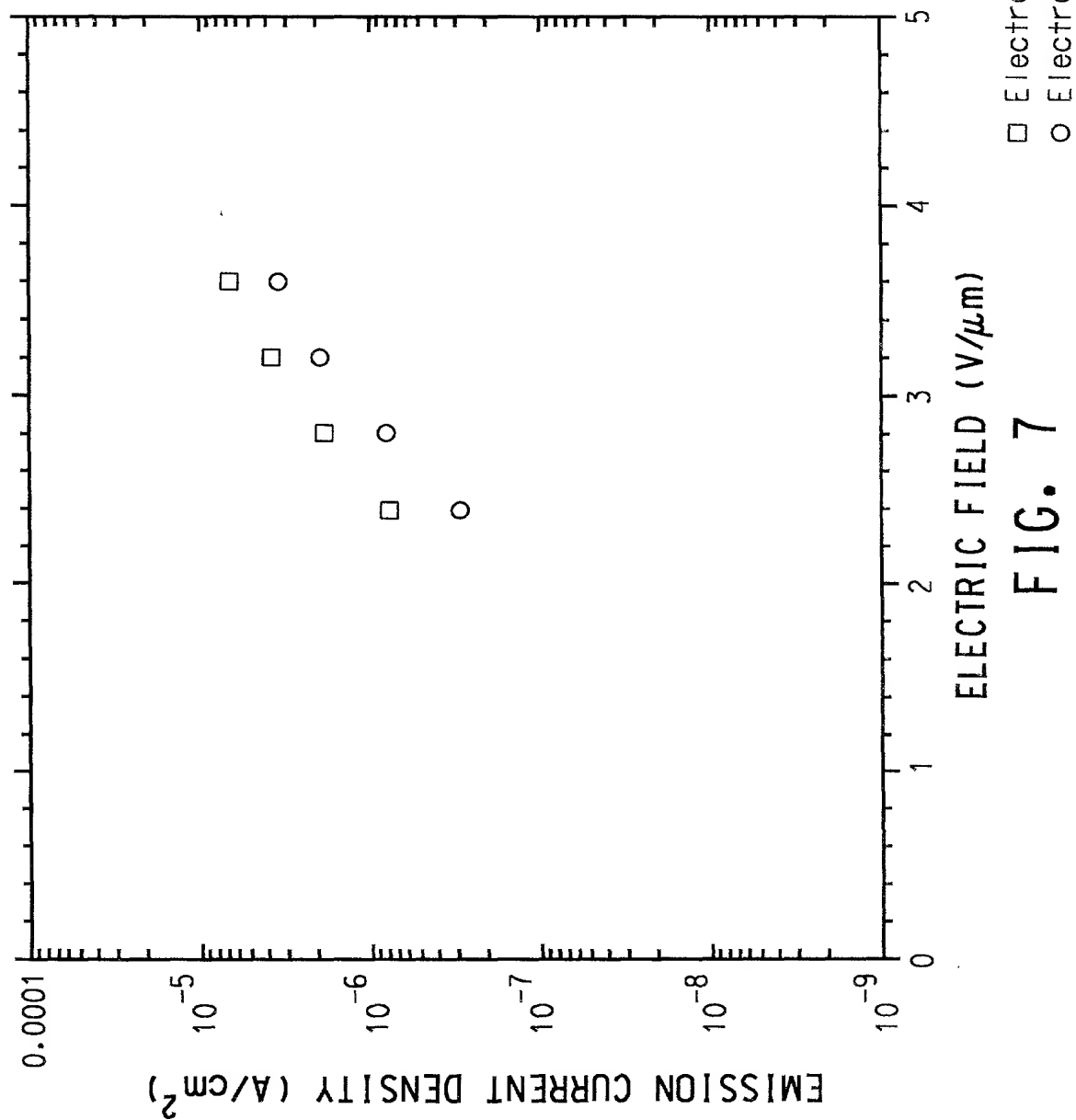


FIG. 6f

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FIG. 8a

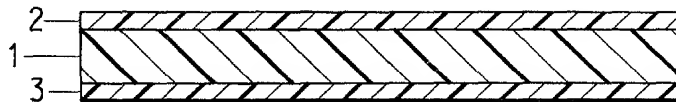


FIG. 8b

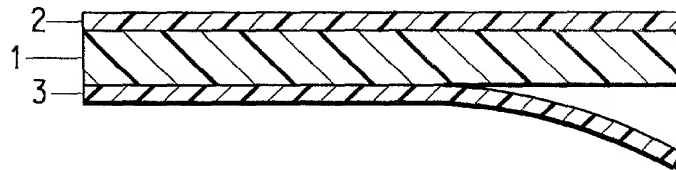


FIG. 8c

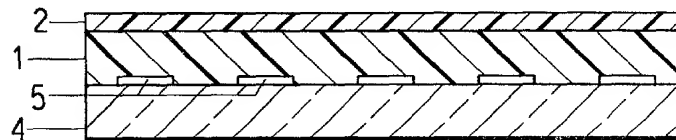


FIG. 8d

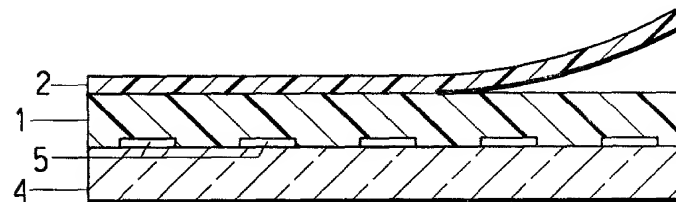


FIG. 8e

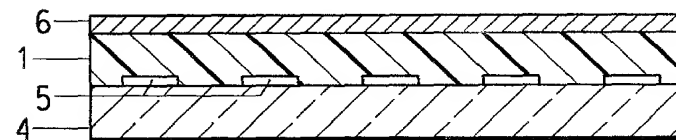


FIG. 8e



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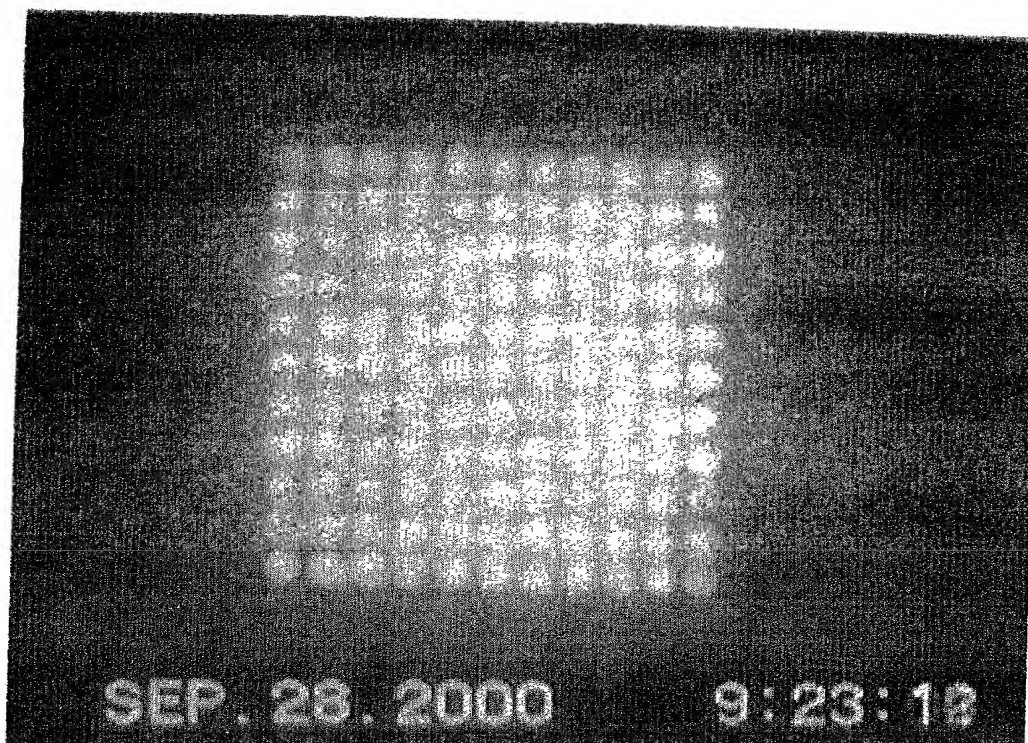


FIG. 9a

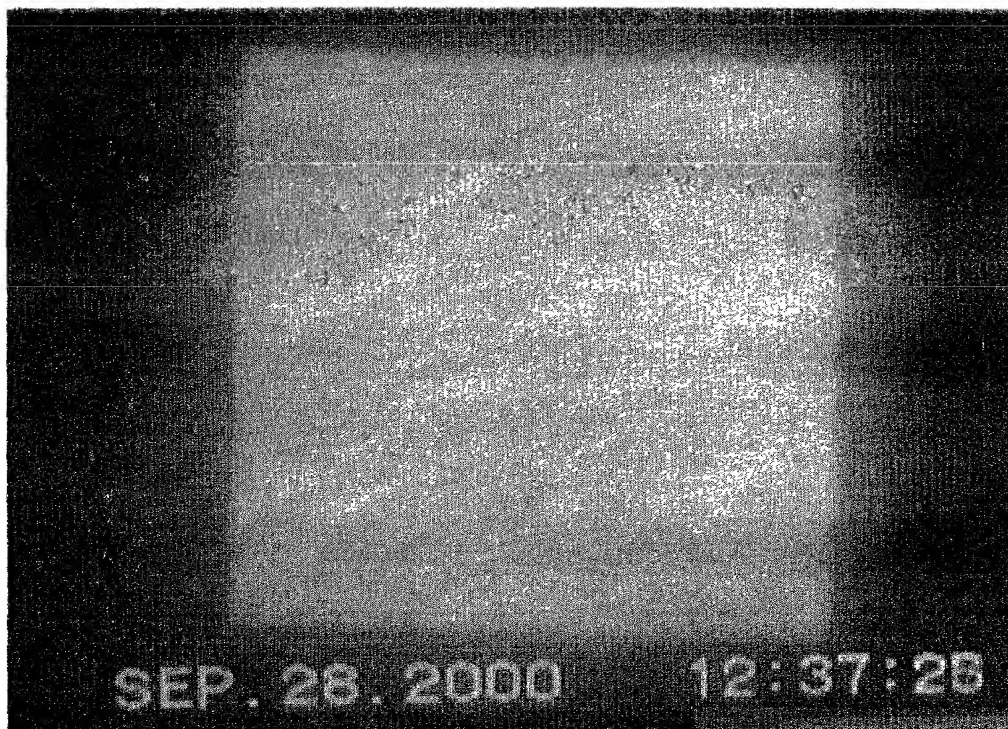


FIG. 9b

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Docket No: CL-1673
Title: Process for Improving The Emission Of Electron Field Emitters
Inventor: Robert Joseph Bouchard, et. al.
Appl. No.: 09/882,719
E.I. DuPont de Nemours

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FIG. 10

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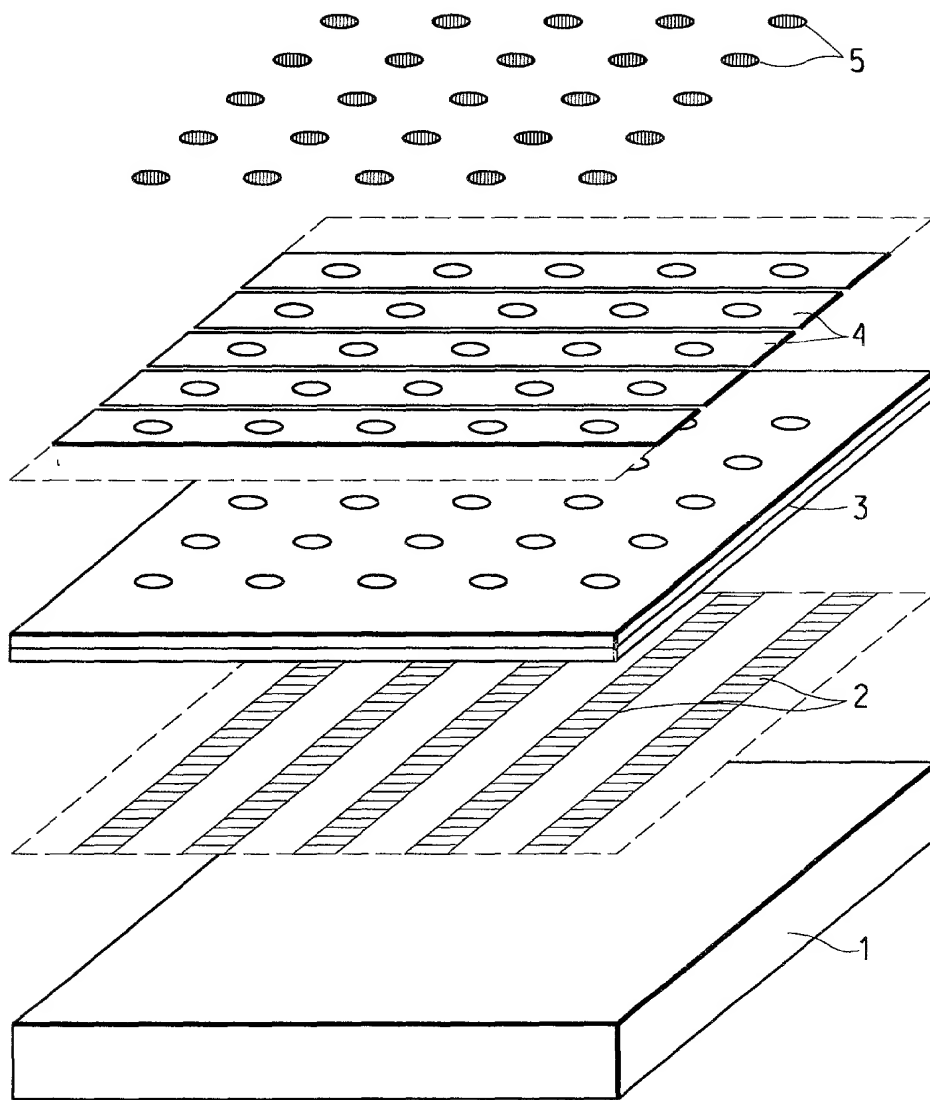


FIG. 11a

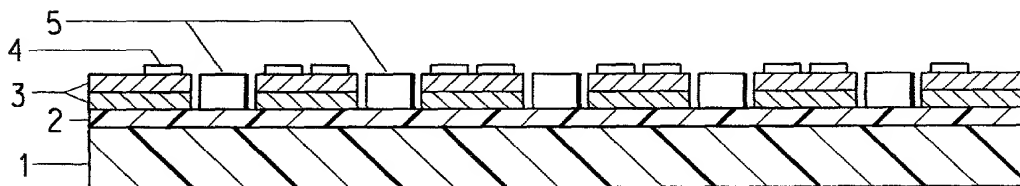


FIG. 11b

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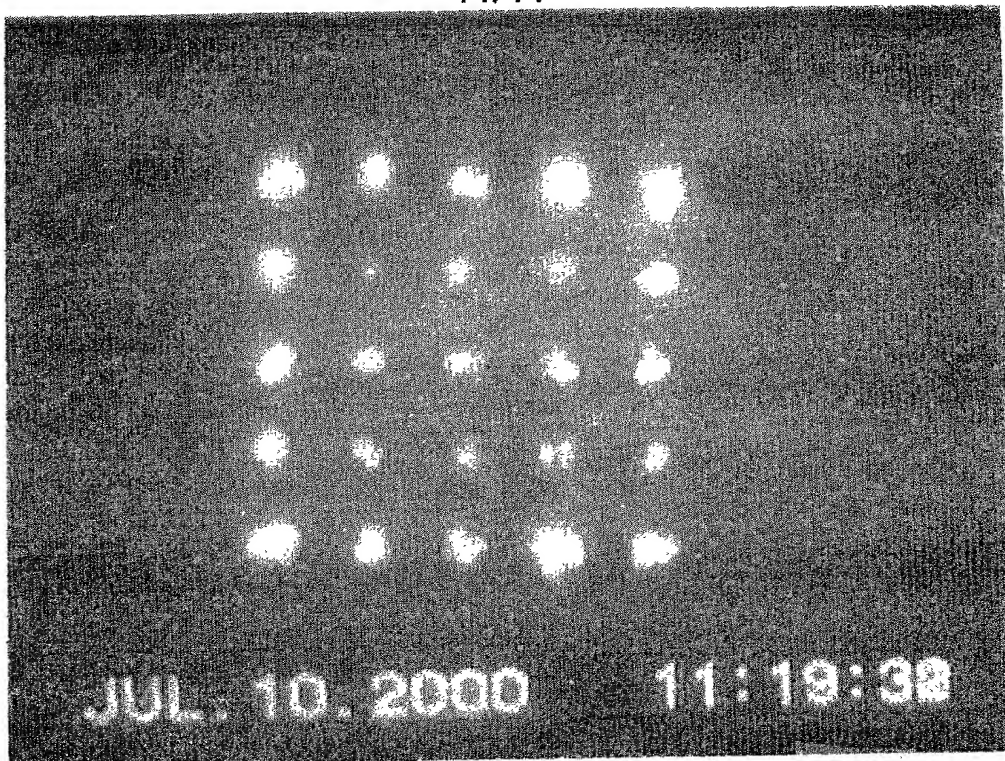


FIG. 12a

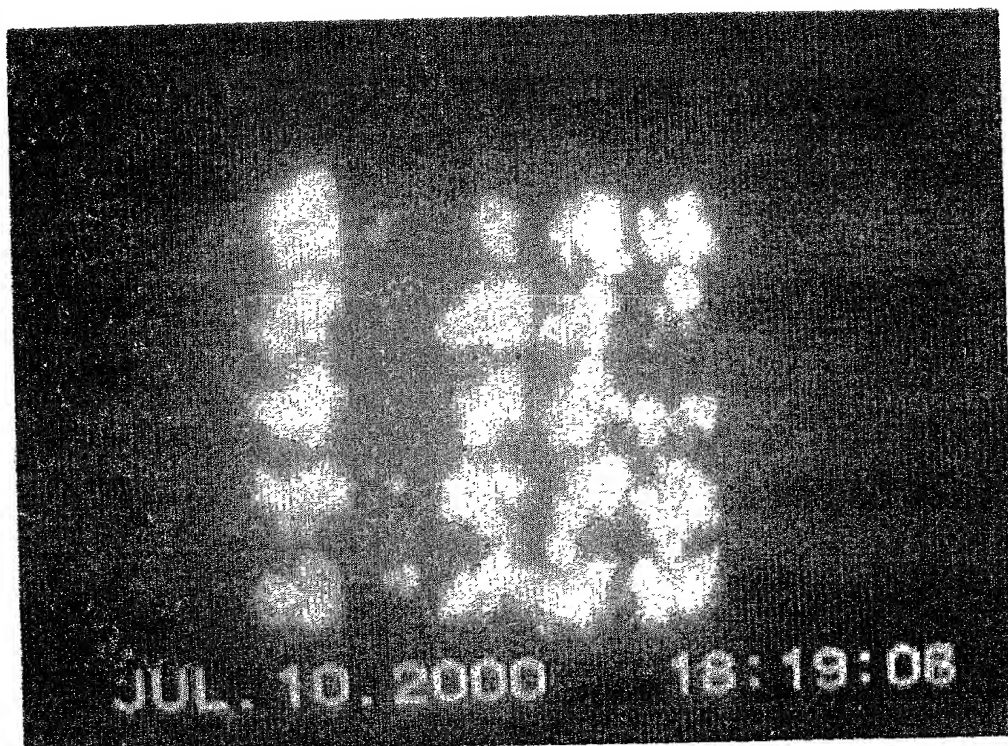


FIG. 12b

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